

EAST - (10 092887 - Amorphous SiC window coating wsp.1)

File View Edit Window Help

**Drafts**

**Pending**

**Active**

L1: (0) (amorphous adj silicon ADJ carbide) WITH (coating or layer) and @pd>20021210

L2: (0) (257/76,77.ccls. 438/105,931.ccls. ) and (amorphous adj silicon ADJ carbide) a

L3: (0) ((257/76,77.ccls. 438/105,931.ccls. ) and (amorphous adj silicon ADJ carbide))

L4: (0) ((electromagnetic adj interference) with shield) same film and @pd>20021210

L5: (0) ((electromagnetic adj interference) with shield) same (thin adj film) and @pd>

L6: (0) (amorphous adj silicon ADJ carbide) with (conductivity or resistivity) and @pd

L7: (0) (amorphous adj silicon ADJ carbide) and ((glue or bonding or adhesive or bonde

L8: (0) (amorphous adj silicon ADJ carbide) with (thin adj film) and @pd>20021210

**Failed**

**Saved**

(1168) (amorphous adj silicon ADJ carbide) WITH (coating or layer)

(1256) 257/76,77.ccls. 438/105,931.ccls.

(2) (amorphous adj silicon ADJ carbide) and (electromagnetic adj interference)

(72) (257/76,77.ccls. 438/105,931.ccls. ) and (amorphous adj silicon ADJ carbide)

(13) ((257/76,77.ccls. 438/105,931.ccls. ) and (amorphous adj silicon ADJ carbide)) an

(1) ((257/76,77.ccls. 438/105,931.ccls. ) and (amorphous adj silicon ADJ carbide)) and

(1) ((257/76,77.ccls. 438/105,931.ccls. ) and (amorphous adj silicon ADJ carbide)) and

(2) (amorphous adj silicon ADJ carbide) and (emi)

(3) (amorphous adj silicon ADJ carbide) and (electromagnetic with interference)

(2) 6031250.pn.

(2) 6269229.pn.

(1) "09/557165"

USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM\_TDB

2002/12/12 13:17

2002/12/12 13:18

2002/12/12 13:18

2002/12/12 13:19

2002/12/12 13:20

2002/12/12 13:21

2002/12/12 13:21

2002/12/12 13:22

Type	L#	Hits	Search Text	DBs	Time Stamp
BRS	L1	0	(amorphous adj silicon ADJ carbide) WITH (coating or layer) and @pd>20021210	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2002/12/12 13:17
BRS	L2	0	(257/76,77.ccls. 438/105,931.ccls. ) and (amorphous adj silicon ADJ carbide) and @pd>20021210	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2002/12/12 13:18
BRS	L3	0	((257/76,77.ccls. 438/105,931.ccls. ) and (amorphous adj silicon ADJ carbide)) and (transparent with light) and @pd>20021210	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2002/12/12 13:18
BRS	L4	0	((electromagnetic adj interference) with shield) same film and @pd>20021210	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2002/12/12 13:19
BRS	L5	0	((electromagnetic adj interference) with shield) same (thin adj film) and @pd>20021210	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2002/12/12 13:20
BRS	L6	0	(amorphous adj silicon ADJ carbide) with (conductivity or resistivity) and @pd>20021210	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2002/12/12 13:21
BRS	L7	0	(amorphous adj silicon ADJ carbide) and ((glue or bonding or adhesive or bonded) adj layer) and @pd>20021210	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2002/12/12 13:21
BRS	L8	0	(amorphous adj silicon ADJ carbide) with (thin adj film) and @pd>20021210	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2002/12/12 13:22

File View Edit Window Help

Print

updated EAST search 12/12/02

## Dialog DataStar

[options](#)[logout](#)[feedback](#)[help](#)[databases](#)[easy search](#)

## Advanced Search: INSPEC - 1969 to date (INZZ)

[limits](#)

## Search history:

No.	Database	Search term	Info added since	Results	
1	INZZ	high ADJ temperature SAME pressure ADJ sensor AND silicon ADJ carbide	unrestricted	11	<a href="#">show titles</a>
2	INZZ	1 AND cavity	unrestricted	1	<a href="#">show titles</a>

[hide history](#)Enter your search term(s): [Search tips](#)

whole document



Information added since:

or:

none

[search](#)

(YYYYMMDD)

Select special search terms from the following list(s):

updated INSPEC search  
12/12/02